



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hiroshi MORIOKA et al.**

Group Art Unit: **1756**

Application Number: **10/692,722**

Examiner: **Daborah C. Davis**

Filed: **October 27, 2003**

Confirmation Number: **9699**

For: **MICRO PATTERN FORMING METHOD AND SEMICONDUCTOR  
DEVICE MANUFACTURING METHOD**

Attorney Docket Number: **032045**

Customer Number: **38834**

**RESPONSE UNDER 37 C.F.R. §1.114**

**MAIL STOP RCE**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

May 18, 2006

Sir:

In response to the Office Action dated March 13, 2006, Applicants amend the claims as follows and submit the following remarks.

**Amendments** to the Claims begin on page **2** of this paper.

**Remarks/Arguments** begin on page **9** of this paper.